Form 1449 (Modified)	Atty. Docket No.	Application No.:		
	HIT1P050/	Unassigned		
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Information Disclosure	Applicant:			
Statement By Applicant	Donald Ray Gillis et al.			
]	Filing Date:	Group Art Unit:		
(Use Several Sheets if Necessary)	Herewith	Unassigned		

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Foreign Patent or Published Foreign Patent Application

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Examiner		Document	Publication	Country or		Sub-	Trans	slation
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.